



## FORM PTO-1449

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LIST OF PATENTS AND PUBLICATIONS FOR  
APPLICANT'S INFORMATION  
DISCLOSURE STATEMENT

Applicant: Cabuz et al.

Filing Date:	Group Art:
December 27, 2000	2812

## U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
<i>[initials]</i>	4,855, 544	8/8/1999	Glenn			
<i>[initials]</i>	5,013,681	5/1991	Godbey et al.			
<i>[initials]</i>	5,343,064	8/1994	Spangler et al.			
<i>[initials]</i>	5,542,558	8/1996	Benz et al.			
<i>[initials]</i>	5,866,469	2/1999	Hays			
<i>[initials]</i>	5,994,204	11/1999	Young et al.			
<i>[initials]</i>	6,277,666	8/2001	Hays et al.			
<i>[initials]</i>	2001/002907	10/2001	Kuwahara et al.			
<i>[initials]</i>	6,372,609	4/2002	Aga et al.			

## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Country	Translation Yes No
<i>[initials]</i>	WO 0078667 A	12/28/2000	PCT	

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>[initials]</i>	Mochida, Y., et al., "A micromachined vibrating rate gyroscope with independent beams for the drive and detection modes", Sensors and Actuators A, 80 (2000) pages 170-178.
<i>[initials]</i>	Puers, R., et al., "Design and processing experiments of a new miniaturized capacitive triaxial accelerometer", Sensors and Actuators A 68 (1998) pages 324-328.
<i>[initials]</i>	Xiao, Zhixiong, et al., "Silicon micro-accelerometer with mg resolution, high linearity and large frequency bandwidth fabricated with two mask bulk process", Sensors and Actuators 77 (1999), pages 113-119.

EXAMINER: *[initials]*DATE CONSIDERED: *5/16/03*

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.